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In re Application of:

Docket No. 00862.022032.

HIROSHI TSUJI ET AL.

Application No.: 09/691,234

Examiner: J. Berman

Filed: October 19, 2000

Group Art Unit: 2881

For: ELECTRON BEAM LITHOGRAPHY APPARATUS

Date: February 24, 2003

THE COMMISSIONER FOR PATENTS  
Washington, D.C. 20231

RECEIVED  
MAR - 6 2003  
TECHNOLOGY CENTER 2800

Sir:

Transmitted herewith is an amendment in the above-identified application.

No additional fee is required.

The fee has been calculated as shown below

CLAIMS AS AMENDED						
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	* 20	MINUS	** 20	0	x \$9 \$18	0
INDEP. CLAIMS	* 4	MINUS	*** 4	0	x \$42 \$84	0
Fee for Multiple Dependent claims \$140°/\$280						0
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT---						0

- \* If the entry in Column 2 is less than the entry in Column 4, write "0" in Column 5.
- \*\* If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.
- \*\*\* If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space.

°Verified Statement claiming small entity status is enclosed, if not filed previously.

A check in the amount of \$ \_\_\_\_\_ is enclosed.

Charge \$ \_\_\_\_\_ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.

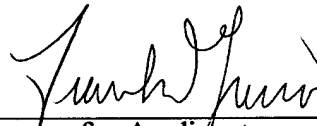
Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.

A check in the amount of \$ 930.00 to cover the fee for a three-month extension is enclosed.

A check in the amount of \$ \_\_\_\_\_ to cover the Information Disclosure Statement fee is enclosed.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



\_\_\_\_\_  
Attorney for Applicants

Registration No. 42426

FITZPATRICK, CELLA, HARPER & SCINTO  
30 Rockefeller Plaza  
New York, New York 10112-3801  
Facsimile: (212) 218-2200

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00862.022032.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
 :  
 HIROSHI TSUJI ET AL. )  
 :  
 Application No.: 09/691,234 )  
 :  
 Filed: October 19, 2000 )  
 :  
 For: ELECTRON BEAM LITHOGRAPHY )  
 APPARATUS :  
 : February 24, 2003

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 A.Walk

Commissioner For Patents  
 Washington, D.C. 20231

REQUEST FOR APPROVAL TO SUBSTITUTE DRAWINGS

Sir:

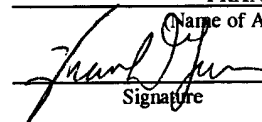
With the Examiner's approval, Applicants propose to substitute the attached sheets 15/26-20/26 (Figs. 15-20) for the sheets 15/26-20/26 (Figs. 15-20) originally filed in the above-identified application as follows:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231 on February 24, 2003.

(Date of Deposit)

FRANK A. DeLUCIA

(Name of Attorney for Applicant)

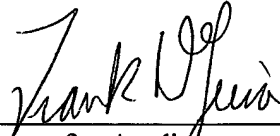
  
 Signature

February 24, 2003

Date of Signature

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our below listed address.

Respectfully submitted,



Attorney for Applicants

Registration No. 42476

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